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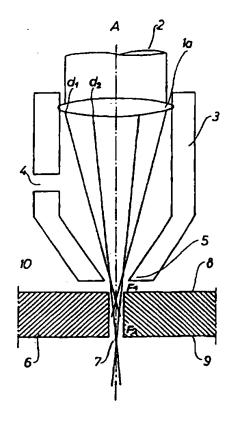
Before the expiration of the time limit for amending the claims and to be republished in the event of the receipt of amendments.

In English translation (filed in Danish).

(54) Title: A METHOD OF PROCESSING A MATERIAL BY MEANS OF A LASER BEAM

(57) Abstract

A method of processing a material with a first and a second surface (8, 9) by means of a laser beam (2), which is focused by means of a multilens objective in a number of focal points $(F_1, F_2...F_n)$, which are approximately positioned on a common axis with an angle to the first surface (8). The focal points are spaced apart and used for cutting plates, several focal points being utilized for melting/cutting the plate material. As a result a good cutting notch is obtained with a poor adhering of slags and a good separation of the cut parts.



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Title: A method of processing a material by means of a laser beam.

Technical Field

The invention relates to a method of processing a material with a first and a second surface by means of a laser beam which for instance by means of a multilens objective is focused in a number of focal points, where said focal points are approximately positioned on a common axis forming an angle with the first surface and are spaced apart.

Background Art

German Auslegeschrift No. 2,713,904 discloses a way of processing an article by means of a laser beam, said laser beam being focused in two focal points by means of a multilens objective. This processing method is used for drilling holes, whereby one focused bundle of rays is used for a melting of the surface of the article and the second bundle of rays presents a focal point positioned below the focal point of the first bundle of rays and is used for preheating the area surrounding the location of the article to be melted so as subsequently to be removed by way of evaporation. Such a processing method avoids to a certain degree formation of burrs at the edge of the hole. The lower focal point is, however, not utilized.

20 A growing demand has applied within the material processing industry employing lasers for a possibility of cutting in thick plates, such as steel plates of a thickness of 15 mm or more. As the cutting capacity of the laser beam is best on or adjacent the surface it is focused on, problems apply to transferring the effect to portions of the plate positioned below said surface. Moreover, the second surface of the material is encumbered with problems of an increased amount of adhering slags and a poor cutting quality, which inter alia results in a poor separation of the cut parts and

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may necessitate a finishing processing.

Brief Description of the Invention

The object of the invention is to provide a method of processing material by means of a laser, which ensures an improved processing quality in connection with thick materials. Furthermore, the expenditure of protecting gases must be low.

A method of the above type is according to the invention used for cutting plates, whereby several focal points are utilized for melting/cutting the plate material. The multilens objective has the effect that the total bundle of rays is relatively narrow, whereby the nozzle for protecting gases and consequently the expenditure of said protecting gases can be reduced correspondingly. It is well known that the protecting gases are very important for the quality and the cut.

According to a preferred embodiment of the invention, the focal points are positioned at a fixed distance relative to one another and to the first and the second surface.

It is advantageous for the complexity of the focusing optical instruments when the number of focal points is two.

It is furthermore advantageous when the distance between the head comprising the optical instruments and the first surface can be increased in such a manner that the focal point adjacent the second surface during the cutting can be caused to be positioned on the first surface, the so-called starting holes thereby being provided in an improved manner. In addition, the risk of the optical instrument being damaged by metal sprayings has been reduced.

A further advantage is found in connection with ignition, melting and removal of melt and slags by at least one of the focal points being positioned between the first and the second surface, adjacent the second surface or adjacent the first and the second surface, respectively.

In order to facilitate the penetration of the laser beam into the cutting notch it is furthermore advantageous when the focusing optical instruments focus the laser beam in several focal points, the distance of which from the second surface is increased concurrently with an increasing distance of the light from the central axis of the laser beam in such a manner that the central portion of the laser beam is focused in the focal point adjacent the second surface.

Brief Description of the Drawing

Two embodiments of the invention are described in greater detail below with reference to the accompanying drawing, in which

- 15 Fig. 1a illustrates a laser cutting head with transmittent optical instruments,
 - Fig. 1b illustrates a laser cutting head with reflecting optical instruments,
 - Fig. 2a shows a transmittent optical instrument forming three focal points,
 - Fig. 2b shows a reflecting optical instrument forming three focal points,
- 20 Fig. 3<u>a</u> illustrates the cutting head of Fig. 1<u>a</u> at a distance from the surface, and
 - Fig. $3\underline{b}$ illustrates the cutting head of Fig. $1\underline{b}$ at a distance from the surface.

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Best Mode for Carrying Out the Invention

Reference is first made to Fig. 1a, where a plate 6 to be cut by means of a laser is shown. The plate comprises a first surface 8 and a second surface 9. A movable, integrated optics/nozzle system, also called a cutting 5 head 10, is provided above the first surface 8 of the plate 6. The cutting head 10 is movable in a plane parallel to the first surface 8 of the material to be cut in, whereby optional shapes can be cut in said material. The latter is known per se and is therefore not discussed in greater detail. Furthermore the cutting head 10 is movable to a predetermined degree perpendicular to the first surface 8 in such a manner that during the cutting it can enter an optimum distance relative to a flow of cutting gas and the focusing of the laser beam 2.

The cutting head 10 comprises a pressure chamber 3 with an inlet opening 4 allowing a continuous filling of cutting gases into said pressure chamber 3, as well as an outlet opening 5 directing the gas towards the cutting location. The gas used depends on the material to be cut, but typically it is oxygen in connection with ordinary steel to be burnt away, or an inert gas, such as nitrogen, in connection with stainless steel being melt away.

In addition, the cutting head 10 comprises an optical instrument 1a, 1b, 21a, 21b focusing a laser beam 2 in a number of focal points F₁, F₂,, F_n. These focal points are scattered on a common axis A, which forms an angle, typically a right angle with the first surface 8 of the material to be cut. These focal points F₁, F₂,, F_n are interspaced a fixed distance relative to one another and relative to the first and the second surface 8, 9 of the material. For illustrative reasons, the Figures 1a and 1b are diagrammatic vies of a cutting notch 7, in which the focal point F is positioned.

In the embodiment shown in Fig. 1, the optical instrument 1a, 1b is

formed such that the central portion of the instrument, i.e. within d_2 , focuses the central portion of the laser beam 2 in the focal point F_2 adjacent the second surface 9 of the material, whereas the circumferential portion outside d_2 focuses the outer portion of said laser beam 2 in the focal point F_1 adjacent the first surface 8 of the material. In the illustrated embodiment, the focal point F_1 is placed above the surface 8 in view of the cutting, but it is also possible to place all the focal points F_1 , F_2 , ..., F_n between the first and the second surface 8, 9.

The optical instrument can be structured in many ways. The Figures illustrate simple embodiments using a lens 1a or a mirror 1b.

The Figures $2\underline{a}$ and $2\underline{b}$ show embodiments of optical instruments $21\underline{a}$, $21\underline{b}$ with several focal points F_1 , F_2 , ..., F_n , only three being illustrated for the sake of clarity. In this case, the focal points of respective concentric portions of the optical instrument $21\underline{a}$, $21\underline{b}$ are formed such that the focal length decreases concurrently with an increasing distance from the centre.

The distance between the entire cutting head 10 and the first surface is variable in such a manner that during the starting procedure it can be increased whereby the focal point F_2 ordinarily positioned adjacent the second surface 9 during the cutting can be caused to be positioned on the first surface. The resultingly increased distance between the cutting head 10 and the first surface 8 reduces the risk of sprayings of melt material returning through the nozzle 5 so as to destroy the optical instruments 1a, 1b, cf. Figures 3a and 3b where the diagrammatic cutting notch 7 has been maintained for illustrative reasons so as to provide an improved view of the beam passage, but said notch does not, of course, exist before the cutting has been initiated.

Although the embodiments include simple lens members, it is also possible to use more complicated arrangements, such as combinations of lenses

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which in combination form the desired number of focal points.

It is also possible to a certain degree to deviate from the exact axial positioning of the focal points or the right angle of this axis with the surface without deviating from the basic idea of the invention. Such a procedure is for instance possible as long as it is advantageous for the cutting speed that the cutting in the deep layers is performed involving a minimum displacement relative to the layers thereabove.

<u>Claims</u>

- 1. A method of processing a material with a first and a second surface (8, 9) by means of a laser beam (2), which for instance by means of a multilens objective is focused in a number of focal points $(F_1, F_2, ..., F_n)$, which are positioned approximately on a common axis forming an angle with the first surface, and which are spaced apart relative to one another, used for cutting plates, several focal points being utilized for melting/cutting the plate material.
- 2. The use as claimed in claim 1, c h a r a c t e r i s e d in that the 10 focal points $(F_1, F_2, ..., F_n)$ are fixed spaced apart from one another and from the first and the second surface (8, 9).
 - 3. The use as claimed in claim 1 or 2, characterised by the number of focal points $(F_1, F_2, ..., F_n)$ being two.
 - 4. The use as claimed in one of the preceding claims 1 to 3, c h a r-5 a c t e r i s e d by at least one of the focal points (F₁, F₂, ..., F_n) being positioned between the first and the second surface (8, 9) adjacent the second surface (9) or adjacent the first and the second surface, respectively.
 - 5. The use as claimed in one of the preceding claims 1 to 4, c h a r 20 a c t e r i s e d by the focal point ordinarily being positioned adjacent the second surface (9) during the staring of the cutting being caused to be positioned on the first surface (8).
- 6. The use as claimed in one of the preceding claims 1 to 5, c h a r a c t e r i s e d by the central portion of the laser beam (2) being focused in the focal point (F₁) adjacent the second surface (9).

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7. The use as claimed in one of the preceding claims 1 to 6, c h a r - a c t e r i s e d by the focusing optical instruments (1a, 1b, 21a, 21b) focusing the laser beam (2) in several focal points (F₁, F₂, ..., F_n), the distance of which from the second surface (9) being increased concurrent- by with the increasing distance of the light from the central axis of the laser beam.

AMENDED CLAIMS

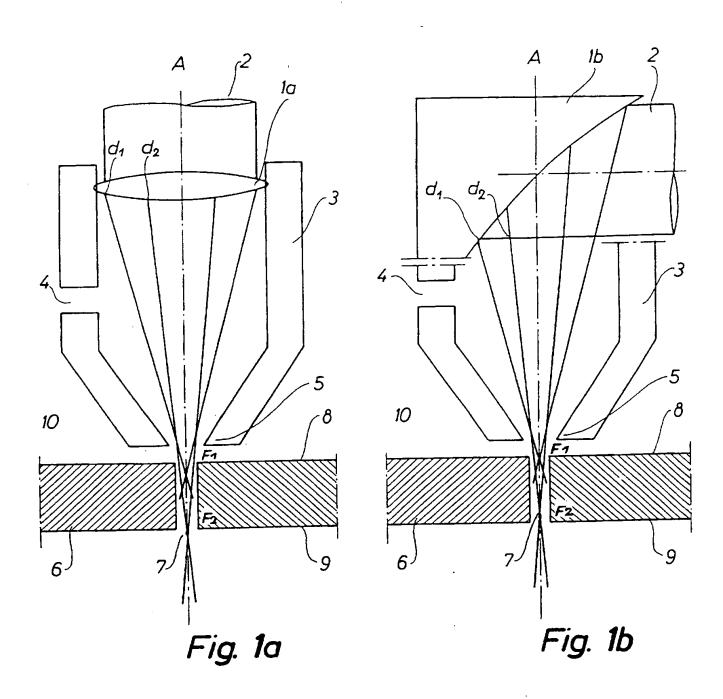
[received by the International Bureau on 20 March 1998 (20.03.98); original claims 1-7 replaced by new claims 1-6 (2 pages)]

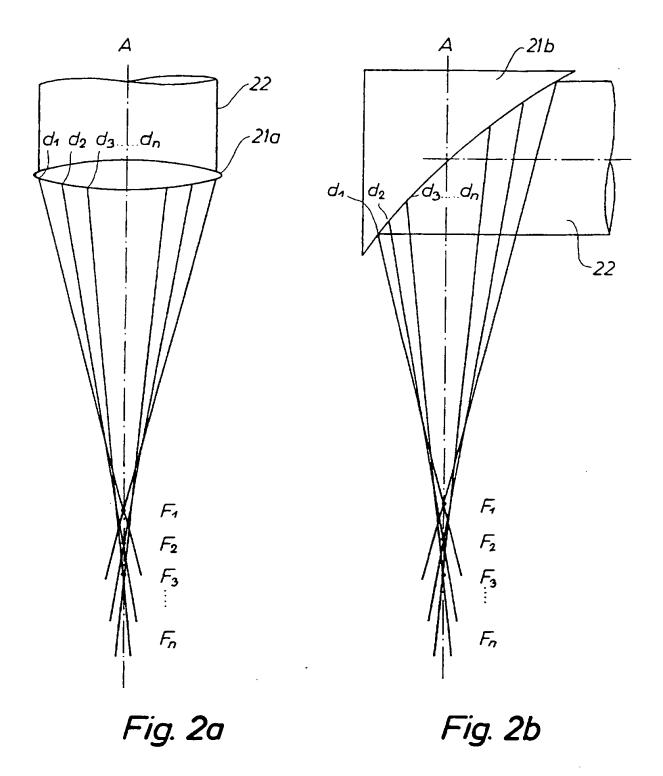
- A method of processing a material with a first and a second surface (8, 9) by means of a laser beam (2), which for instance by means of a multilens objective is focused in a number of focal points (F₁, F₂, ...F_n), which are positioned approximately on a common axis forming an angle with the first surface, and which are spaced apart relative to one another, used for cutting plates, several focal points being utilized for melting/cutting the plate material, the central portion of the laser beam (2) being focused in the focal point (F₁) adjacent the second surface (9).
- 10 2. The use as claimed in claim 1, c h a r a c t e r i s e d in that the focal points $(F_1, F_2, ..., F_n)$ are fixed spaced apart from one another and from the first and the second surface (8, 9).
 - 3. The use as claimed in claim 1 or 2, characterised by the number of focal points $(F_1, F_2, ..., F_n)$ being two.
- 15 4. The use as claimed in one of the preceding claims 1 to 3, c h a r a c t e r i s e d by at least one of the focal points (F₁, F₂, ..., F_n) being positioned between the first and the second surface (8, 9) adjacent the second surface (9) or adjacent the first and the second surface, respectively.
- 20 5. The use as claimed in one of the preceding claims 1 to 4, c h a r a c t e r i s e d by the focal point ordinarily being positioned adjacent the second surface (9) during the staring of the cutting being caused to be positioned on the first surface (8).
- 6. The use as claimed in one of the preceding claims 1 to 5, c h a r 25 a c t e r i s e d by the focusing optical instruments (1<u>a</u>, 1<u>b</u>, 21<u>a</u>, 21<u>b</u>) focusing th laser beam (2) in several focal points (F₁, F₂, ..., F_n), the

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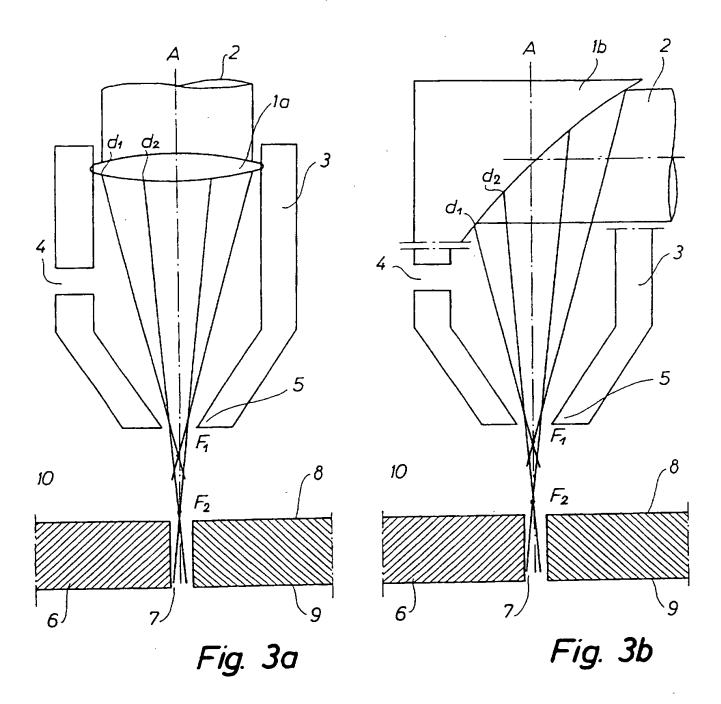
distance of which from the second surface (9) being increased concurrently with the increasing distance of the light from the central axis of the laser beam.

AMENDED SHEET (ARTICLE 19)





SUBSTITUTE SHEET (RULE 26)



A. CLASSIFICATION OF SUBJEC	TE MATTER				
IPC6: B23K 26/06 According to International Patent Classific	cation (IPC) or to both	national classification and l	PC:		
B. FIELDS SEARCHED					
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Documentation scarched other than minim	ium documentation to ti	he extent that such docume	nts are included in	the fields searched	
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C. DOCUMENTS CONSIDERED	TO BE RELEVANT				
Category* Citation of document, with	egory* Citation of document, with indication, where appropriate, of the relevant passages				
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line 34 - lin	18 July 1991 (18.07.91), column 5, line 34 - line 56, figures 2,3, abstract				
	DE 2713904 A1 (SIEMENS AG), 5 October 1978 (05.10.78), page 5, line 34 - page 8, line 2, figures 1-5				
X US 5521352 A (W.E (28.05.96), c figure 1, abs	olumn 2, line	May 1996 3 - column 3, li	ne 20,	1,2,3,4	
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INTERNATIONAL RCH REPORT

Intermedial application No.
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C (Continu	tation). DOCUMENTS CONSIDERED TO BE RELEVANT			
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A	Patent Abstracts of Japan, abstract of JP 56-122690 A (NIPPON DENKI K.K.), 26 Sept 198 (26.09.81)	1	1-7	
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Form PCT/ISA/210 (continuation of second sheet) (July 1992)

INTERNATIONAL SEARCH REPORT Information patent family members

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	atent document I in search repor	ri	Publication date	Patent family member(s)	Publication date
DE	4034745	A1	18/07/91	NONE	
DE	2713904	A1	05/10/78	NONE	
US	5521352	Α	28/05/96	EP 0723491 A WO 9508414 A	31/07/96 30/03/95

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